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Optical Optimization of High Resistance Transparent Layers in Thin Film Cadmium Telluride Solar Cells

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Abstract

Thin film photovoltaic devices are multilayer opto-electrical structures in which light interference occurs. Light reflection at the interfaces and absorption within the window layers reduces transmission and, ultimately, the conversion efficiency of photovoltaic devices. Optical reflection losses can be reduced by adjusting the layer thicknesses to achieve destructive interference within the structure of the cell. The light transmission to the CdTe absorber of a CdS/CdTe cell on a fluorine doped tin oxide transparent conductor has been modeled using the transfer matrix method. The interference effect in the CdS layer and high resistance transparent buffer layers (SnO₂ and ZnO) has been investigated. The modeling shows that due to relatively high absorption within the SnO₂ layer, there are modest benefits to engineering anti-reflection interference in the stack. However, a ZnO buffer layer has limited absorption and interference can be exploited to provide useful anti-reflection effects. Optical modeling and

optimization shows that for a 50nm CdS layer, a maximum transmission of 78.5% is possible using ZnO as a buffer layer at 58nm thickness, and 78.0% for a SnO₂ buffer layer at a thickness of 48nm.

Keywords: Thin film, Optical interference, Anti-reflection Coating, CdTe, Solar cell, Conversion efficiency, High Resistance Transparent layer.

1. Introduction

Thin film CdTe solar cells have achieved commercial success through low manufacturing costs and increasingly high efficiencies. Energy conversion efficiencies of 22.1% have been reported for thin film CdTe solar cells [1]. However, the theoretical efficiency limit for this type of device is ~30% [2]. Both optical and electrical losses occur in CdTe solar cells. Electrical losses are normally of greater magnitude than optical losses, but if light fails to reach the active layer of the stack, a photocurrent is not generated. As such, optical losses precede electrical losses, imposing limitations on photocurrent if not addressed. The losses occur due to reflection and light absorption in layers which do not contribute to the photocurrent, such as the CdS window layer [3].

Light interference effects occur in the multilayer structure of the cell. The reflection losses can be controlled and reduced by tuning the thickness of individual layers to achieve an interference minimum. The absorption losses in the window layer can be reduced by thinning the window layer thickness, which usually requires use of a high resistance transparent layer to prevent voltage and shunt losses [4]. Optical modelling has been used to assess the optical losses within the CdTe solar stack in a simpler model [5], and to evaluate internal reflection losses in a-Si solar cells [6]. In this work, optical modeling was used to investigate how optimizing the various layer thicknesses can increase light transmission to the CdTe absorber layer to increase the photocurrent generated.

1.1.1. The thin film CdTe solar cell

The CdTe solar cell is a thin film stack with a total thickness typically ~3 μ m. For commercial modules, the layers are deposited on to a low cost soda lime glass substrate coated with a transparent conducting

oxide (TCO). NSG Pilkington TEC glass is an industrial standard substrate. The TEC glass consists of SnO₂, SiO₂ and SnO₂:F layers deposited on 3.2mm thick float glass. Depending on the properties required, there are different types of TEC glass characterized by different light transmission, sheet resistance, and surface roughness. TEC 10 glass is an option for CdTe solar cells. The glass is characterized by 70% light transmission in the AM1.5 solar spectrum and a 9 Ω/□ sheet resistance [7].

The CdTe solar cell is deposited onto a TCO coated glass. A simple cell structure consists of CdS-CdTe hetero-junction and a back contact. The CdS layer is usually ~100nm thick. The CdS acts as an n-type semiconductor and enables the photovoltaic effect in the solar cell. The band-gap of CdS is 2.4eV which corresponds to an absorption edge at ~500nm. The photons absorbed in the window layer do not contribute to the photocurrent of the solar cell, as recombination is very likely to occur, resulting in scattering of light. Therefore, absorption in the CdS layer is a source of significant loss. In a typical cell utilizing CdS, the photocurrent is limited to 22-23mA/cm², although 31mA/cm² is available in the spectrum utilized by CdTe absorber [8], [9].

CdTe is a semiconductor material with a band-gap of 1.45eV which corresponds to an 850nm absorption edge. Soda lime glass absorbs light at wavelengths of 350nm and below [10]. Optically, therefore, the CdTe device absorbs wavelengths between 350nm and 850nm.

The ideal refractive index of a typical single layer anti-reflection coating is the product of the refractive indices of the materials at the media interface, square rooted [11](equation 1).

$$n_c = \sqrt{n_0 n_1} \quad (1)$$

In equation 1, n_c is the refractive index of the coating, n_0 is the refractive index of the incident material, and n_1 is the refractive index of the substrate material.

1.1.2. High resistance transparent (HRT) buffer layers

High resistance transparent buffer layers have been shown to improve solar cell efficiencies by reducing the necessary thickness of the CdS layer and reducing shorting through the CdS layer [12], [13].

The buffer layer is located between the CdS layer and the fluorine doped tin oxide TCO layer. The refractive indices are 1.9 and 2.5 respectively, at the maximum in the AM1.5 spectrum $\sim 550\text{nm}$ wavelength. Using equation 2, the ideal refractive index to maximize transmission at a wavelength of 550nm is ~ 2.2 . The refractive indices of ZnO and SnO₂ are 2.0 and 1.9 respectively. As the refractive index of ZnO is closer to that of an ideal anti-reflection layer in the 350nm to 850nm region, the destructive interference of reflections from different interfaces within the system is more complete. This results in lower reflection minima when ZnO is implemented as the buffer layer.

Bulk SnO₂ is a transparent n-type semiconductor with a band-gap of 3.6eV and a refractive index of ~ 1.9 at 550nm [14], [15]. Thin film SnO₂ has been used as a HRT buffer layer in CdTe solar cells at a variety of thicknesses between 12.5nm and 100nm [16]. Figure 1 shows the structure of a thin film CdTe solar cell incorporating an HRT buffer layer. It has been shown that the inclusion of a SnO₂ HRT buffer layer in a standard CdTe/CdS solar cell, with Fluorine doped tin oxide transparent conducting oxide, leads to a 90mV improvement to open-circuit voltage (V_{oc}) and a 6% improvement in Fill Factor [16]. The inclusion of a SnO₂ HRT_buffer layer has a negligible effect on spectral response and J_{sc} , whilst raising the shunt resistance of the device [16].

An alternative HRT buffer layer material to SnO₂ is Zinc Oxide (ZnO). The refractive index of ZnO at 550nm is ~ 2.0 and the band-gap of ZnO is $\sim 3.3\text{eV}$ [17]. ZnO has been modeled previously as a HRT buffer layer in CdTe solar cells using a thickness of 115nm [18]. The addition of a ZnO HRT buffer layer has been shown to be beneficial to CdS/CdTe solar cell efficiency [19]. ZnO has also been used as a HRT buffer layer in Cu(InGa)Se₂ (CIGS) solar cell devices [20].

The dispersion relationships and absorption coefficients of SnO₂ and ZnO are shown in figures 2 and 3 respectively.



Figure 1 A schematic diagram of the CdTe solar cell structure showing the position of (from bottom to the top), the back contact, the CdTe absorber, the CdS window layer, the buffer layer, the TCO layer, and the glass substrate.

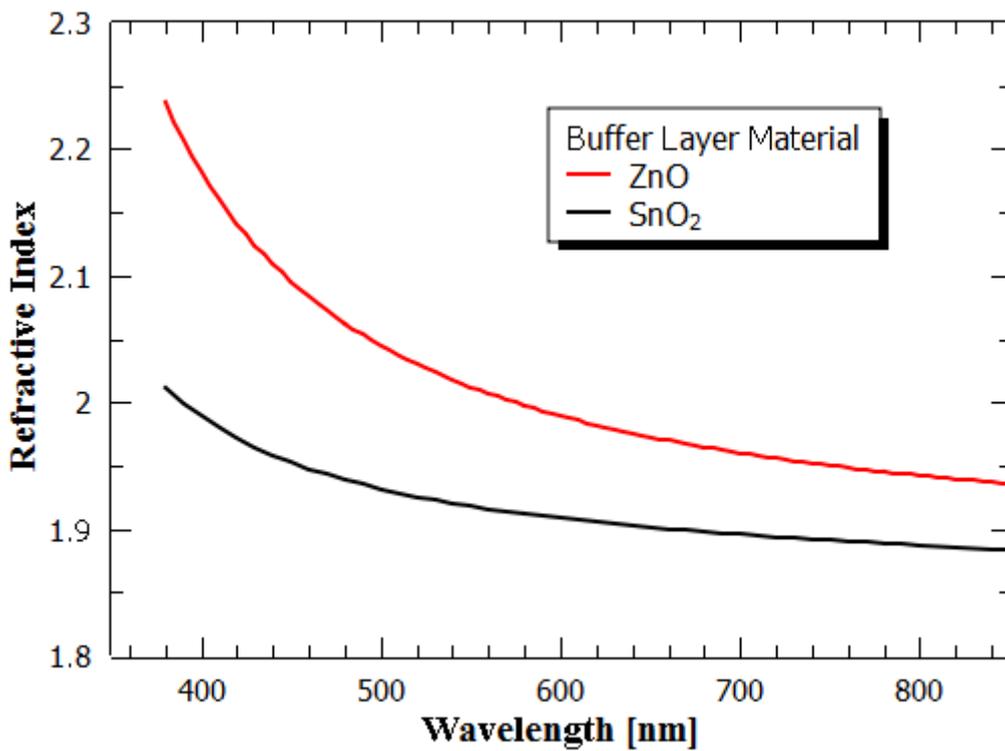


Figure 2 The refractive index dispersion for SnO₂ and ZnO, the candidate high resistance buffer layer materials.

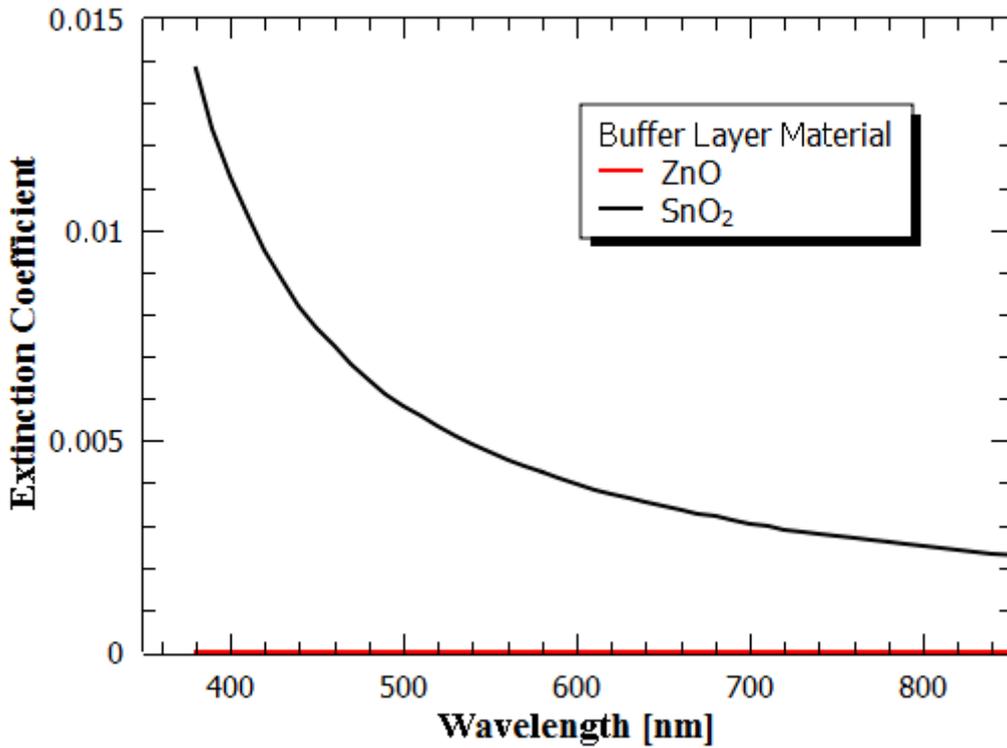


Figure 3 The extinction coefficients of SnO₂ and ZnO, the candidate high resistance buffer layer materials.

2. Optical modeling

The thin film CdTe solar cell was modeled and optimized for maximum light transmission to the CdTe layer, using software based on the transfer matrix method [21]. The performance of the solar cells was assessed by calculating the weighted average transmission (WAT) of light into the CdTe absorber in the 350nm – 850nm spectral range, by incorporating the photon flux in the AM1.5g solar spectrum (Φ) [22].

$$WAT(\lambda_{max}, \lambda_{min}) = \frac{\int_{\lambda_{min}}^{\lambda_{max}} \Phi \cdot T d\lambda}{\int_{\lambda_{min}}^{\lambda_{max}} T d\lambda} \quad (2)$$

Initially, a simple solar cell consisting of TEC10 substrate with a CdS (thickness 50nm - 300nm) and CdTe junction was modeled for comparison. Complete light absorption in the CdTe layer was assumed. Such devices can usually achieve ~12% conversion efficiency with a photocurrent of 22mA/cm² [2], [4]. The effect of the addition of a HRT buffer layer on the optical performance was then modeled. Because thicknesses below 50nm are not electrically viable, the buffer layer materials initially were investigated

at thicknesses in the range 50nm to 500nm. However, low thickness HRT buffer layer interference effects were investigated at select thicknesses of CdS, despite being electronically unsuitable. TEC 10 glass has a sheet of fluorine doped tin oxide (FTO) with a sheet resistance of $9\Omega/\square$ and a thickness of 350nm. Therefore, to create an accurate model of a possible CdTe cell design the TCO layer was modeled as a FTO layer at a thickness of 350nm.

The refractive index and extinction coefficient data for CdS and SnO₂ were measured using a Horiba, Jobin Yvon, UVISEL Spectroscopic ellipsometer. The refractive index and extinction coefficient for ZnO was obtained from Sun and Kwok [23]. The refractive index and extinction coefficient values for CdTe were taken from the Handbook of the Optical Constants of Solids I [24].

3. Results

3.1.1. Varying the thickness of the CdS layer

The effect of modeling the variation in the thickness of the CdS layer was investigated. The effect of varying thickness was first modeled in a stack without a HRT buffer layer. The results are shown in figure 4. The CdS thickness reduces light transmittance to the CdTe layer at all thicknesses. The thin film CdS is usually between 50nm and 150nm thick in CdTe devices [25]. Figure 4 shows that the optical transmission is highly sensitive to the thickness of the CdS layer. Transmittance is 77.9% at 50nm thickness, but at 300nm it reduces dramatically to 59.4%.

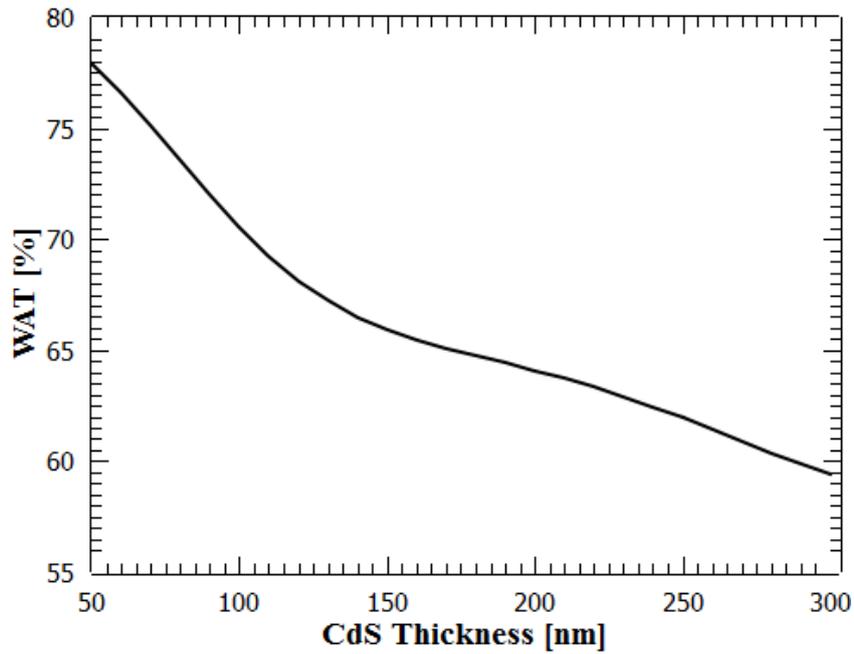


Figure 4 The modeled optical weighted average transmission (WAT) to the CdTe layer in a CdTe photovoltaic device, plotted against the thickness of the CdS layer. The effect of a high resistance buffer layer is not included.

3.1.2. Varying the thickness of the SnO₂ High Resistance Transparent buffer layer

The effect of a SnO₂ HRT buffer layer on transmittance was calculated by varying the thickness of the CdS layer between 50nm and 300nm at 10nm intervals, and by varying the thickness of the SnO₂ layer up to 500nm at 10nm intervals. The optical transmission into the active layer was calculated at each point and a 3D grid was generated from the data. The 3D plot is shown in figure 5.

A maximum transmittance at a CdS thickness of 50nm was calculated to be 78.0% at a SnO₂ layer thickness of 50nm. At thicknesses greater than 70nm the absorbing properties of SnO₂ become more influential and the transmission to the absorber is reduced. Reducing the thickness of the CdS layer to below 50nm increases the transmittance. However, CdS thicknesses below 50nm have not been considered since layers this thin are likely to be discontinuous and lead to shorting of the cell [26].

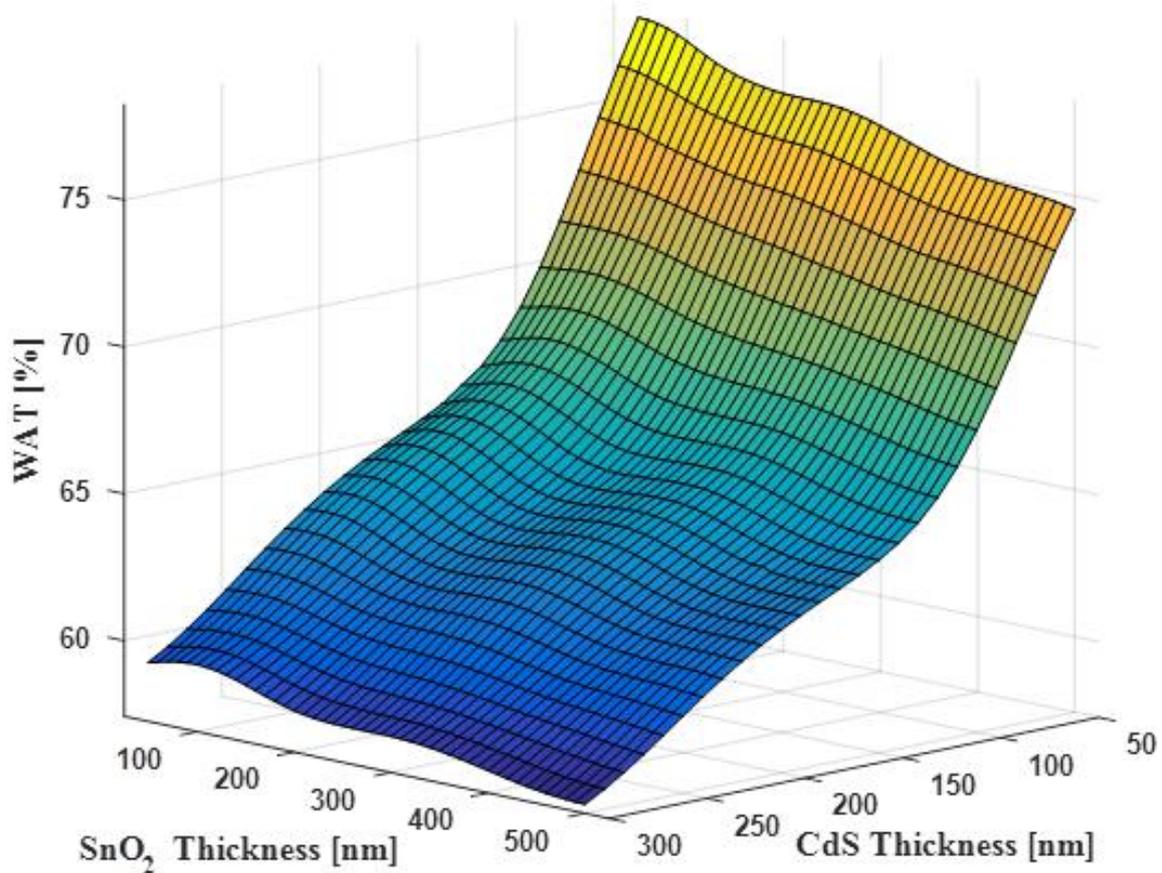


Figure 5 The modeled WAT to the absorbing layer of a CdTe solar cell as a function of CdS and the SnO₂ layer thickness. Thicknesses of CdS and SnO₂ layers (nm) are plotted on the X-Y plane and the modeled value for WAT is plotted along the Z-axis. In this region a maximum transmission occurs at 50nm CdS and 48nm SnO₂.

In practice, it is important to be aware of the effect of thickness tolerance on transmission. It is possible to achieve thickness accuracy, using time control, of +/-2% with magnetron sputtering. Evaporation (thermal or electron beam) can be achieved with similar accuracy using quartz crystal control. Varying the thickness of the CdS and HRT buffer layer around the transmission maximum by 1nm (a variation of +/-2%) results in an insignificant relative loss of 0.002% transmittance. This illustrates the sensitivity of transmission on layer thickness and also confirms that transmission is most sensitive to the CdS layer thickness. The dependence is predominantly flat, indicating that although there is an interference effect, it is not significant in terms of device design. The use of a SnO₂ HRT buffer layer is dictated more on its effect on Voc than any increase in transmission caused by engineering layer thicknesses.

3.1.3. Varying the thickness of the ZnO High Resistance Transparent buffer layer

The thickness of the CdS layer was again varied between 50nm and 300nm at 10nm intervals and the ZnO HRT buffer layer thickness was varied between 50nm and 500nm at 10nm intervals. A value for transmission to the active layer was calculated at each point and a 3D grid was generated from the data. The 3D plot in figure 6 shows how the use of ZnO as a buffer layer results in more significant interference effects. These effects maintain the transmission nearly level across all thicknesses of ZnO. Only a slight decrease in transmission is observed as the ZnO layer thickness is increased. It is also shown that, as with a SnO₂ HRT buffer, the CdS thickness has the greatest effect on transmission to the absorber when a ZnO HRT buffer is used.

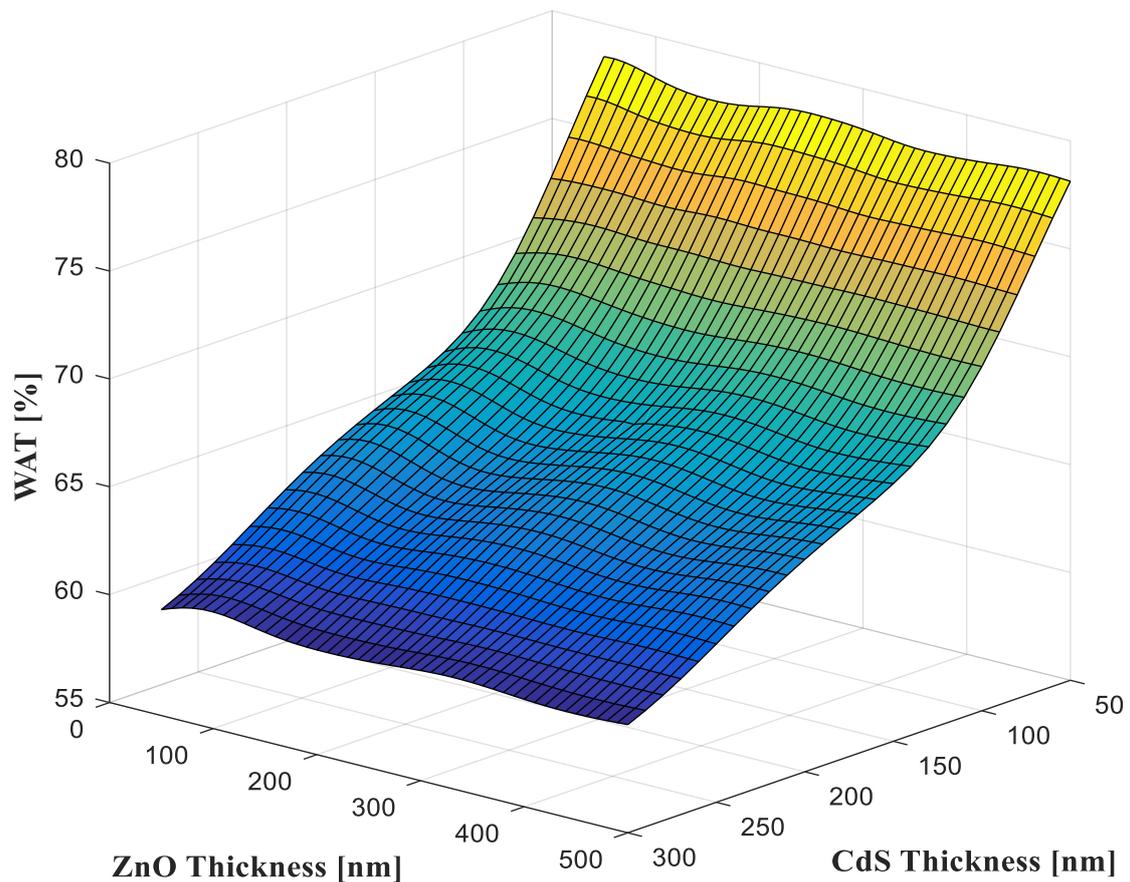


Figure 6 The modeled WAT to the absorber layer for a CdTe solar cell with CdS window and a ZnO high resistance buffer layer. The thickness of the CdS and ZnO layers (nm) are plotted on the X-Y plane and the modeled value for WAT is plotted along the Z-axis.

In general, the addition of a ZnO HRT buffer layer improves light transmission to the absorbing layer, with interference effects resulting in maximum transmission occurring at non-zero thicknesses. Interference effects result in maxima in transmittance at different thicknesses of ZnO at each thickness of the CdS layer. The ZnO layer does not suffer from significant absorption losses as occurs with SnO₂, and therefore thicker HRT buffer layers can be used without significant losses.

A maximum transmittance at a CdS thickness of 50nm was calculated to be 78.5% at a ZnO thickness of 58nm. As with a SnO₂ HRT buffer layer, transmission values can be greater at CdS thicknesses less than 50nm due to the absorbing effect of the CdS layer, but these are disregarded as they are not considered practical. As with SnO₂, variation of +/-2% in ZnO layer thicknesses results in an insignificant relative loss of 0.002%. Therefore, the accuracy of layer thickness control during deposition is achievable with magnetron sputtering or evaporation techniques allied with quartz crystal monitoring.

The addition of a ZnO HRT buffer layer is beneficial to transmission at both 50nm and 100nm CdS thicknesses. The benefits are still present at ZnO thicknesses greater than 100nm, but interference effect maxima occur at different thicknesses of ZnO depending on the thickness of CdS. Consequently, a HRT buffer layer thickness that is beneficial at a CdS thickness of 100nm might be slightly detrimental or relatively less effective at a CdS thickness of 50nm.

3.1.4. A comparison of the optical effects of introducing SnO₂ and ZnO high resistance buffer layers

A direct comparison of transmission to the absorbing layer with a ZnO HRT layer and a SnO₂ HRT layer is provided in figure 7. Although buffer layer thicknesses below 50nm are usually unsuitable, for clarity figure 8 draws out the comparison of the 2 candidate HRT buffer layer materials, highlighting the effect of interference when using thin layers. The HRT buffer layer materials are compared at two CdS layer thicknesses often used in devices, 50nm and 100nm. The comparison shows that the use of ZnO as a HRT buffer layer results in a greater transmission to the CdTe absorber, regardless of the respective thickness of the HRT buffer layer and the CdS layer. The use of SnO₂ is optically beneficial only at certain layer thicknesses.

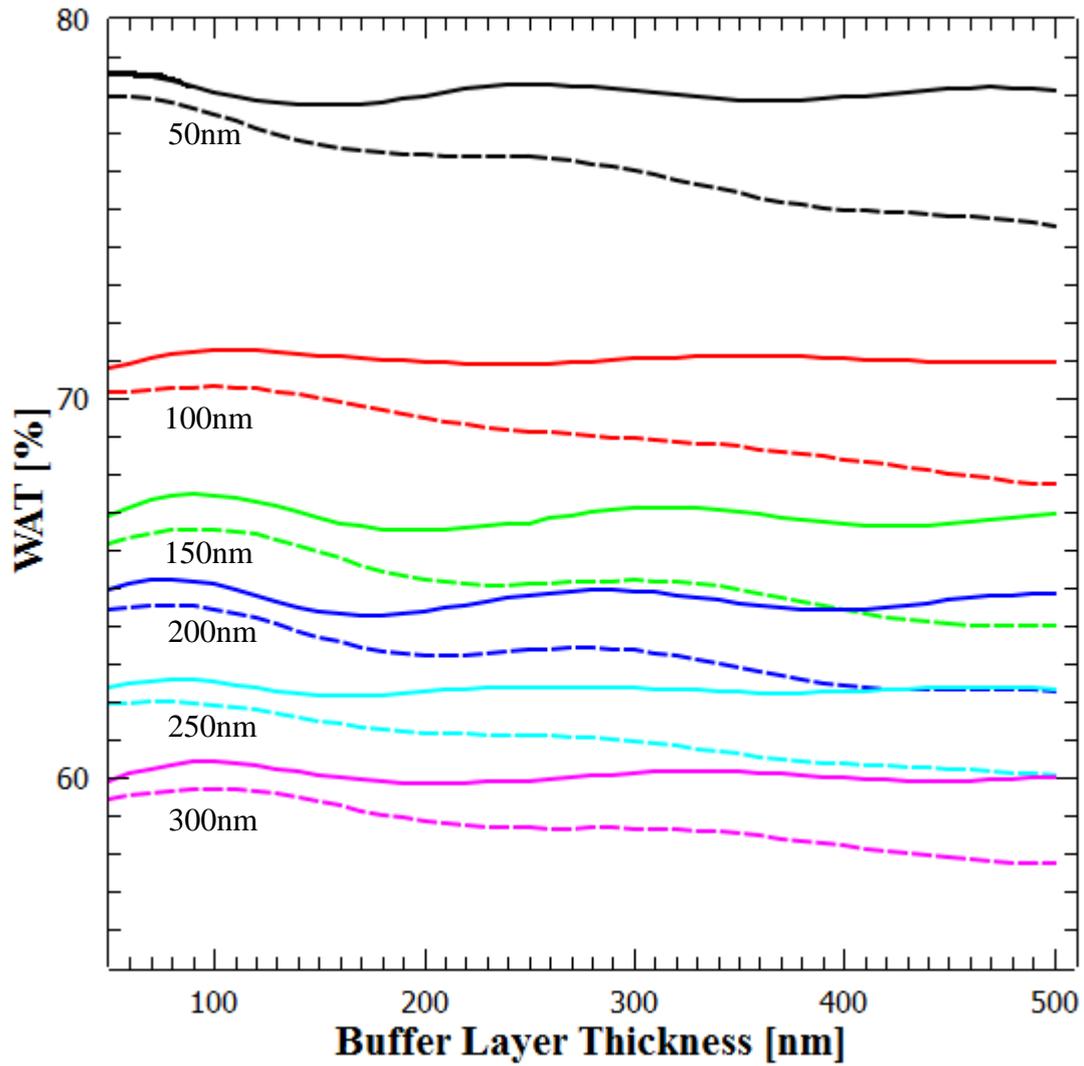


Figure 7 Modeled WAT to the absorber layer of the CdTe stack plotted against thickness for the two candidate HRT layers. ZnO data is represented by solid lines and SnO2 data is represented by dashed lines. Values are given at selected thicknesses of CdS layer; 50, 100, 150, 200, 250 and 300nm.

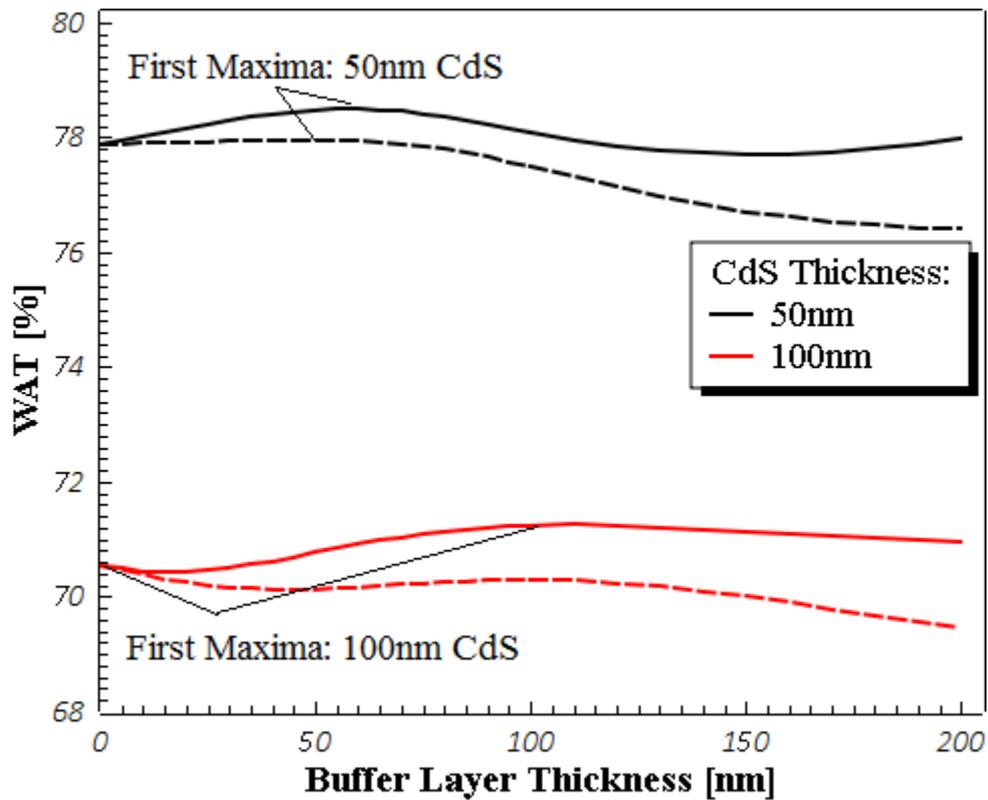


Figure 8 Comparison of modeled WAT to the CdTe layer in the solar cell plotted against the thickness of the ZnO and SnO₂ buffer layers. The ZnO data is represented by solid lines and SnO₂ data is represented by dashed lines. Values are given at selected thicknesses of CdS layer; 50nm and 100nm.

4. Conclusions

Table 1 provides a comparison of the optimization of the optical effects using a SnO₂ or ZnO high resistance transparent buffer layer above the transparent conductor in a thin film CdTe device. Optical interference occurs in the multilayer thin film stack design structure used in thin film CdTe photovoltaic devices. It also occurs in other thin film device structures such as CIGS, CZTS, amorphous Silicon, and perovskite solar cells. It is important to optimize layer thicknesses within the stack to engineer maximum light transmission to the absorber layer so that the highest possible photocurrent is produced. In order to achieve the thickness tolerance required in these optically active layers, control of the deposition rate is key to this process. When considering only optical effects, thickness control in the absorber layer is unimportant once complete absorption is achieved.

Table 1 Comparison of HRT layer performance

	ZnO	SnO₂
Maximum WAT (CdS 50nm)	78.5%	78.0%
Buffer layer thickness at maximum WAT (optimum)	58nm	48nm
WAT at buffer layer 50nm thickness (CdS50nm)	78.5%	78.0%
Absolute transmission gain at optimum HRT layer thickness compared to no buffer layer at 50nm CdS	0.6%	0.1%
Relative maximum transmission loss due to a +/-2% thickness variation at maximum transmission	0.002%	0.002%

The maximum transmission possible using a SnO₂ HRT buffer layer was calculated to occur with 50nm of CdS and 48nm of SnO₂. At these values, the beneficial interference effects of incorporating a SnO₂ layer increases transmission and outweighs the absorption effects within the SnO₂ layer. The transmission gained by optimising HRT and CdS layer thicknesses would lead to a gain in photocurrent of 0.6% for ZnO and 0.1% for SnO₂. Incorporation of the optimized SnO₂ layer leads to a maximum weighted average transmission (WAT) of 78.0%. Varying the thickness of the HRT and CdS layers around maximum transmission by +/-2%, results in an insignificant transmittance loss of 0.002%. This tolerance is achievable by using magnetron sputtering, or thermal/electron beam evaporation using quartz crystal control.

The maximum WAT of 78.5%, using a ZnO buffer layer with a 50nm CdS layer, was calculated to occur using a thickness of 58nm. Therefore it is possible to use a thicker HRT layer for ZnO than SnO₂ which could have electrical benefits. Varying thickness of a ZnO HRT layer around maximum transmission by +/-2% also resulted in negligible losses, similar to those calculated for SnO₂ (0.002%). However, testing a layer thickness tolerance of +/-5nm (~+/-10%) resulted in an absolute WAT loss of 1%, which is significant. Therefore, layer thickness control is important.

The anti-reflection properties of a ZnO HRT layer are more pronounced than those for the SnO₂ HRT layer. This is due to better refractive index matching between the HRT layer, the window layer, and the

TCO. Moreover, the ZnO HRT layer has low absorption losses, so the interference effect can be exploited at greater thickness to minimize the reflection losses.

The work presented in this paper has shown that the use of a ZnO HRT buffer generally results in a higher WAT than SnO₂ at all layer thicknesses. The maximum WAT transmission achievable is 78.5% which is 0.5% greater than the maximum achievable with SnO₂. ZnO also has a greater maximum transmission at 58nm thickness compared to SnO₂ at 48nm thickness. The layer thickness of ZnO can be increased while still retaining increases in transmission. This is important in practice because one of the benefits of incorporating a high resistance layer is the prevention of shorting. This is more likely to be successful as the thickness of the high resistance layer increases.

The application of a multilayer anti-reflection coating has been shown to further increase the transmission to the active layer by reducing reflection from the glass-air interface by 70% [22], [27]. Optical modeling has shown that the use of a broadband anti-reflection coating at the glass-air interface has a negligible effect on the optimization of the thicknesses of layers in the CdTe thin film device.

It should be recognized that this paper has considered only optical interference effects to maximize light transmission to the absorber layer, thereby maximising the current density. Electrical benefits also accrue from the insertion of a high resistance transparent buffer layer which increases Voc. Consequently, the choice of material will be influenced by a combination of optical and electrical effects.

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